Notice of References Cited

S .. 14

Application/Control No. 10/608,103		Applicant(s)/Patent Under Reexamination CHO ET AL.		
E	Examiner	Art Unit		
Ι,	Jennifer M. Kennedy	2812	Page 1 of 2	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,686,212 B1	02-2004	Conley et al.	438/3
	В	US-6,720,259 B2	04-2004	Londergan et al.	438/680
	С	US-6,645,882	11-2003	Halliyal-et al.	438/785
	D	US-6,580,111 B2	06-2003	Kim et al.	257/301
	Ε	US-6,165,841 A	12-2000	Kim et al.	438/255
	F	US-2003/0235947 A1	12-2003	Park et al.	438/253
	G	US-2003/0232501 A1	12-2003	Kher et al.	438/689
	Ι	US-2003/0168750 A1	09-2003	Basceri et al.	257/915
	1	US-6,660,660 B2	12-2003	Haukka et al.	438/778
	J	US-6,653,186 B2	11-2003	Won et al.	438/253
	К	US-6,693,004 B1	02-2004	Halliyal et al.	438/240
	L	US-6,703,277 B1	03-2004	Paton et al.	438/287
	М	US-6,740,554 B2	05-2004	Yang et al.	438/240

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	a	- -				
	R					
	S					
7						· · · · · · · · · · · · · · · · · · ·

NON-PATENT DOCUMENTS

		TON-I ATEN DOCUMENTO
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	x -	. 1

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

U.S. Patent and Trademark Office PTO-892 (Rev. 01-2001)

Notice of References Cited

Jeunese IIIIZ

Notice of References Cited

Application/Control N 10/608,103		Applicant(s)/Patent Under Reexamination CHO ET AL.		
Examiner	Art Unit			
Jennifer M. Kennedy	2812	Page 2 of 2		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,258,691 B1	07-2001	Kim, Yun-Gi	438/398
	В	US-6,576,947 B1	06-2003	Kim, Yun-Gi	257/309
	С	US-6,010,942 A	01-2000	Chien et al.	438/396
	D	US-6,737,313	05-2004	Marsh et al.	438/240
	Е	US-2003/0213987	11-2003	Basceri et al.	257/296
	F	US-6,458,645	10-2002	DeBoer et al.	438/240
	G	US-			
	н	US-			
	ı	US-			
	J	US-			
	к	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

						· ,
*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р	•				
	σ					
	R					
	S			,		
	T _					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al. Silicon Processing for the VLSI Era, Volume 1- Process Technology, Second Edition, 2000, Lattice Press, pages 12 130
	٧	
	w	
	x_	, 1

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

U.S. Patent and Trademark Office PTO-892 (Rev. 01-2001)

Notice of References Cited

Jenuedy 11/ploy